

AF1 Dual Pressure & Vacuum

The only microfluidic instrument in the world able to generate pressure & vacuum on the same channel



Partner modules that can deliver pressure & vacuum on the same channel

Vacuum & Pressure Generator

Generate vacuum & pressure wherever an electric plug is available.

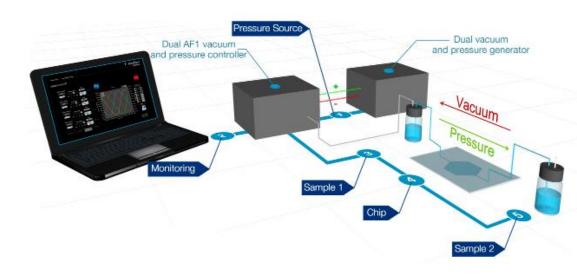
This instrument has been designed to ensure a perfect teamwork with the AF1 Dual Vacuum & Pressure Controller, that would bring the control and accuracy you need. This instrument can also be used independently.

Vacuum & Pressure Controller

Regulate negative & positive pressure on the same channel.

This instrument covers a pressure control range from -700 mbar to 1000 mbar. It has to be linked to an external pressure/vacuum source such as the AF1 Dual Vacuum & Pressure Generator to supply regulated vacuum and pressure.





AF1 Dual **FEATURES & BENEFITS**

> Highest Flow Stability Enjoy a Smooth & Pulseless Flow. The 1mbar flow stability provided by the AF1 Dual ensures a superior flow performance even at low flow rates, to provide you with low-noise data and quality experimental results upon first time.

> Short Response & Settling Time Get the Highest Responsiveness. The piezo technology used for the AF1 enable a blazing fast flow change in your microdevice (100 ms response time,100 ms settlingtime)toperformamazingly dynamic experiments.

> Bi-directional Flow Control Master the Flow.

The -700 mbar to 1000 mbar pressure control range allows you to precisely manage positive and negative flow rates on the same channel with the same instrument.



> Plug & Play Software Interface Shorten the Path to Your Goal.

ESI - Elveflow Smart Interface - controls all Elveflow instruments, letting you automate basic functions to operate all your devices with the same intuitive interface. Seldom used expert functions are out of sight, but just a mouse click away.

Complex Fluidic Profiles Make the Complex Simple.

Our profile editor will allow you to easily create and program sine, triangle, square, sawtooth and pulses flow profiles to automate the most sophisticated protocols.

1 Pressure Source

The AF1 Dual Controller has to be connected to an external pressure source that can be, for instance, the AF1 Dual Generator.

2 Monitoring

Control the outlet pressure (or the flow rate*) of the AF1 Dual Vacuum & Pressure Controller through the Elveflow Smart Interface on your PC.

3 Sample 1

The liquid stored into this reservoir can be injected into your chip using pressure.

4 Chip

The liquid is smoothly and precisely injected into the microfluidic chip.

5 Sample 2

The liquid stored into this reservoir can be sent into your chip using vacuum. * flow sensor required.

to change without notice

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The Elveflow[®] Smart **Interface Makes Your** Work Easier

Thanks to an ergonomic design of the fluidic functions & modules, your routine tasks and workflows will be more comfortable.

- Intuitive control interface
- Real time control using pressure or flow rate regulation
- and recording
- Programming & automation of complex sequences

Alternativeinstrument control through the provided Labview[®] and Matlab[®] libraries, and DLLs



National instruments is our technological partner for embedded electronics



> Portability Performance Anywhere.

The AF1 provides superior portability while keeping performances at high level, to deliver a stable and pulseless fluid flow for the most demanding experiments, anytime, anywhere.

Setup Synchronization **Communication Skills.**

The AF1 offers a TTL triggers set for easilysynchronizingyourinstrument with any Elveflow® device, microscopes or mechanical shutter. That way you can have a full control of all the devices involved in your microfluidic experiment.

Compactness Small, yet Mighty.

Subtleexperimentssometimes require rather significant space. Fortunately, the AF1is shaped to deliver impressive performances while saving valuable lab bench space (220 x 130 x 130 mm Lx1xh).

AF1 **TECHNICAL SPECIFICATIONS**

| AF1 Unit Pressure range Premium | 0 to 200 mbar (0 to 2.9 psi) | 0 to 1600mbar (0 to 23 psi) | Dual Pressure & Vacuum Controller -700 to 1000 mbar (-10 to 14 psi) |
|------------------------------------|---|--|--|
| Type of pressure | Positive | Positive | Negative & Positive |
| Pressure Sensor Resolution | 0.006 % FS 12.2 µbar - 0.00017 psi | 0.006 % FS 122 µbar - 0.0017 psi | 0.006 % FS 122 µbar - 0.0017 psi |
| Pressure stability | 100 µbar (0.0014 psi) i.e. 0.05 % Full Scale | 1 mbar (0.014 psi) i.e. 0.05 % Full Scale | -700 to 500 mBar : 1 mBar 500 to 1000 mBar: 5 mBar |
| Response time | 50 ms | | |
| Settling time | | down to 40 ms $^{\scriptscriptstyle (1)}$ | |
| Supply pressure (min - max) | Integrated pump No pressure source needed | | Pressuresupplyneeded (1.5barmin,2.5barmax) |
| Liquid compatibility | Any aqueous or organic solvent, oil, or biological sample solution can be propelled | | |
| Power consumption | 15 W (100 V to 240 V - 50 Hz to 60 Hz) | | |
| Weight | 1.7 kg | | |
| Case dimensions L x l x h (mm) | 220 x 130 x 130 | | |
| Output connectors | Stainless steel female luer lock | | |

(1) Volume dependent - Measurement done on 12 mL reservoir for a set point from 0 to 200 mbar

AF1 **PRODUCTS & SERVICES**

| Elements provided by Elveflow | Included | Optional |
|--|----------|----------|
| Software & libraries Control all Elveflow® instruments with the same smart interface. | ٠ | |
| AF1 Connection kit A complete set of accessories fitted for the AF1 pressure generator. | | • |
| Kits Connect any pressure source/syringe pump to your device. | | ٠ |
| Reservoirs Gas tight reservoirs with ergonomic fluidic connection. | | ٠ |
| Flow Sensors A line of sensors to monitor very low liquid flow rates. | | ٠ |
| Compressor A safe & secure pressure source for the OB1 pressure controller. | | • |

Related Products & Services



> Eppendorf[®] Microfluidic Tank 100% gas tight connection caps. 1.5 - 2 mL Eppendorf® tubes 15 mL BD Falcon® tubes 100 mL - 2 L Upchurch® bottle caps.



Connection Kits

Bored of microplumbing issues? Our kits enable to easily connect your microfluidic device to any pressure or flow control equipment.



Elveflow instruments are designed to work together on your microfluidic setup. Switch valve system, flow rate monitoring, temperature control...



Benefit from our microfluidics PhD team's expertise. Take advantage of our support for specific developments on your setup.

> Grants & Partnerships

Elveflow invests in co-development and cooperative projects with academic, SME and industrial partners to take an active part in the development of microfluidics.

It is no coincidence that the most prestigious names trust in us









